

IN THE U. S. PATENT AND TRADEMARK OFFICE

In re application of

Rikizo HATAKEYAMA et al.

Conf. 6826

Application No. 10/552,709

Group 4181

Filed July 26, 2006

Examiner H. Chan

METHOD AND APPARATUS FOR PRODUCING
GAS ATOM CONTAINING FULLERENE, AND GAS ATOM
CONTAINING FULLERENE

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 12, 2009

Sir:

In response to the Official Action mailed October 16, 2008, for which the period for response has been extended two months, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.